

# From nanophysics research labs to cell phones

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**Department of Physics**  
**associate professor**



Curriculum Vitae

Birth: 1976.



High-school graduation: 1994.



Master degree: 1999.



PhD: 2003.



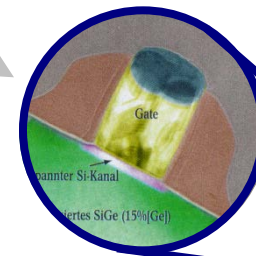
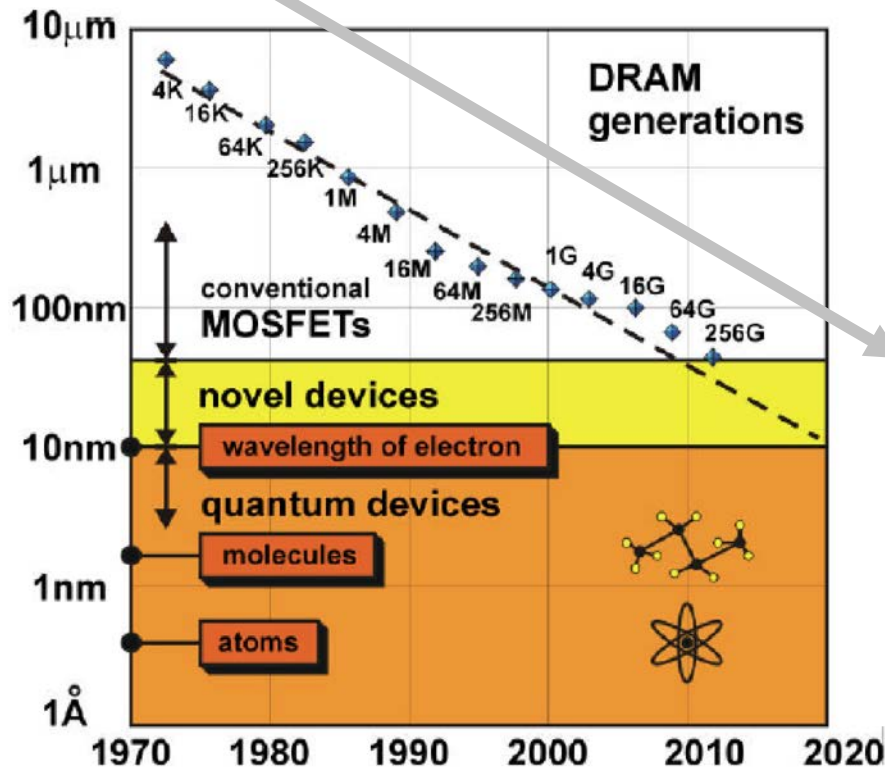
# Nanocircuits in our pocket



## First semiconductor transistor

Shockley, Bardeen, Brattain  
Nobel prize 1956.

**Moore's law:** the characteristic size of electronic building blocks (e.g. transistors) decreases by one order of magnitude within less than 20 years

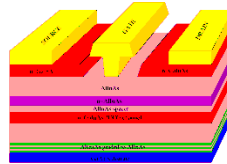




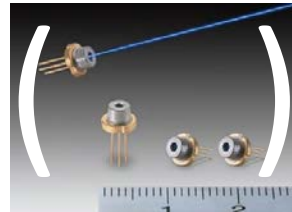
# Nobel prize science in a cell phone



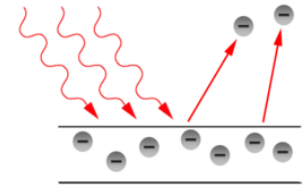
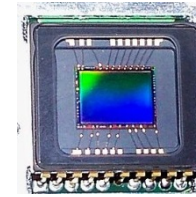
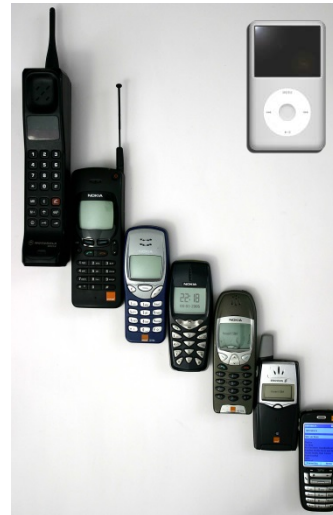
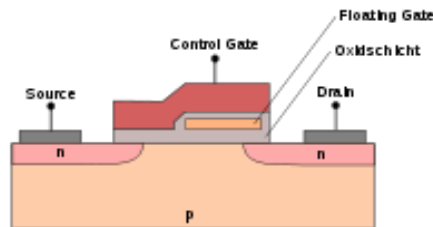
**GHz communication, high electron mobility transistor, semiconductor laser**



Alferov, Kroemer-  
Nobel prize 2000.  
(semiconductor nanostructures)



**SIM card,**  
electron tunneling  
Esaki - Nobel prize 1973.

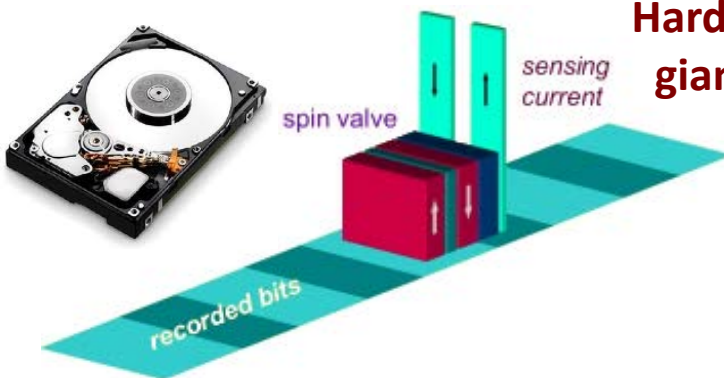


**CCD camera**

Einstein - Nobel prize 1921.  
(photo effect)

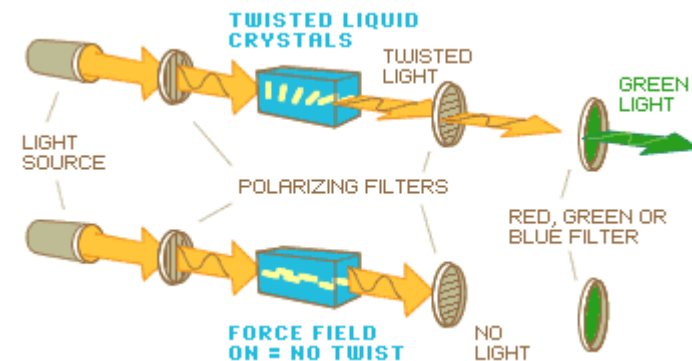
Boyle, Smith - Nobel prize 2009.  
(CCD sensor)

**LCD display,**  
de Gennes -  
Nobel-prize 1991.  
(liquid crystal)



**Hard disk drive read head -  
giant magnetoresistance  
(GMR)**

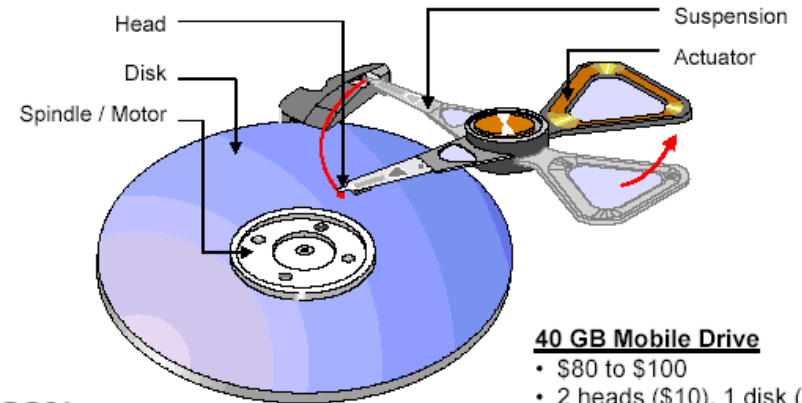
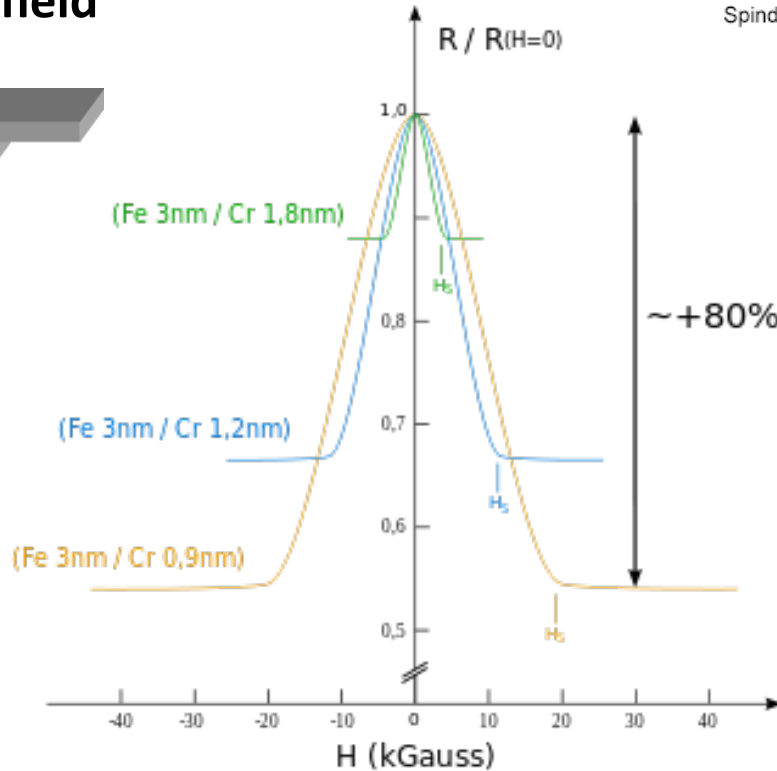
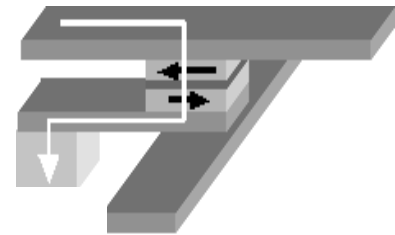
Fert, Grünberg -  
Nobel prize: 2008.



# Spin valve sensor

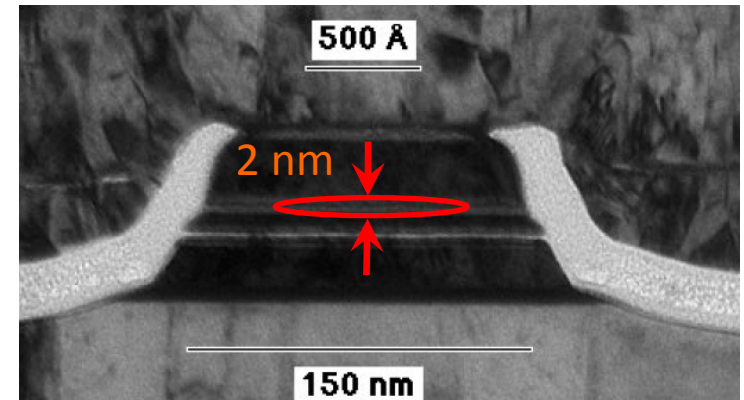


## Application: measurement of magnetic field



### 40 GB Mobile Drive

- \$80 to \$100
- 2 heads (\$10), 1 disk (\$5)
- 40 Gbit/in<sup>2</sup> to 80 Gbit/in<sup>2</sup>



1988: GMR discovery  
1991: spin-valve

1997: HD read head

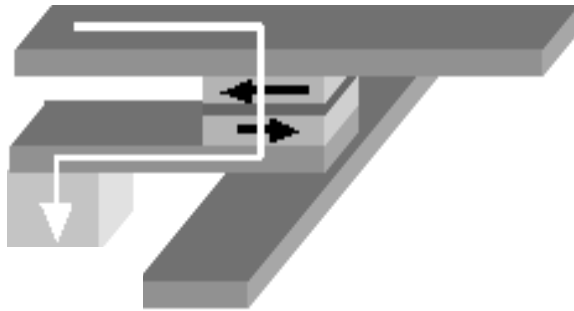
2007: Nobel prize

1990

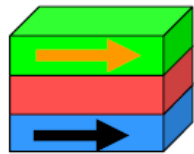
2000

2010

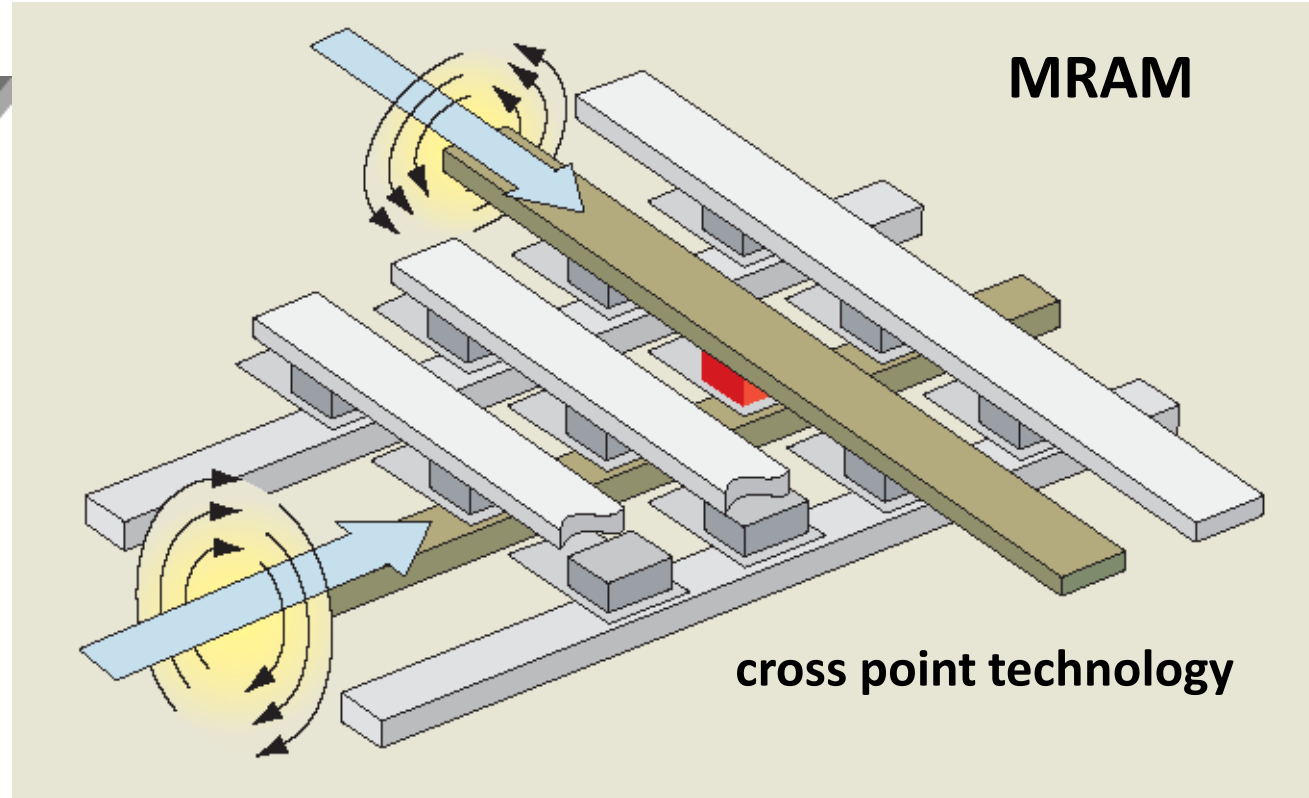
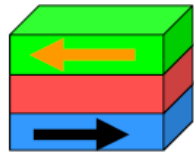
# Spin valve memory



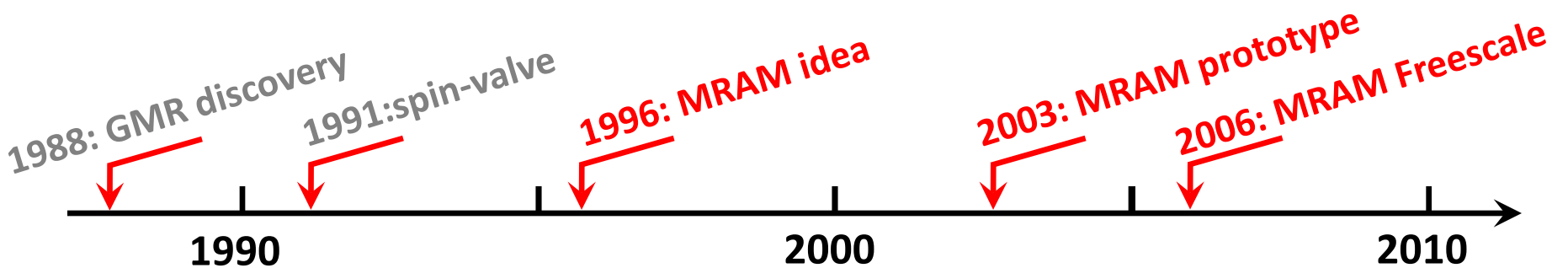
"0"



"1"



**M**agnetoresistive **R**andom **A**ccess **M**emory

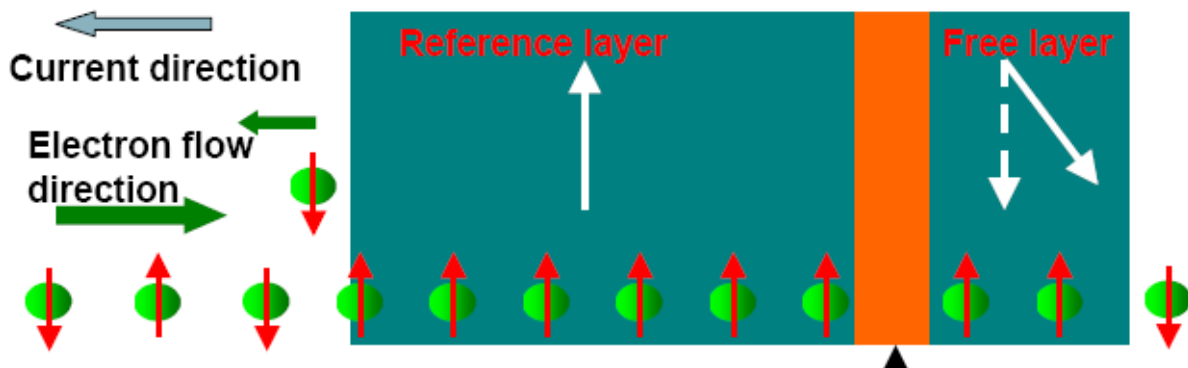


# Switching a spin valve by its current

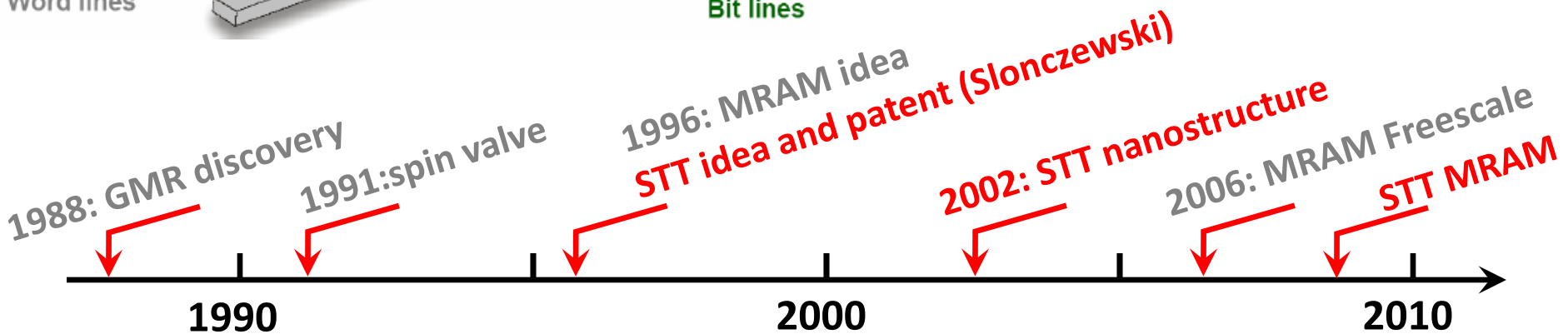
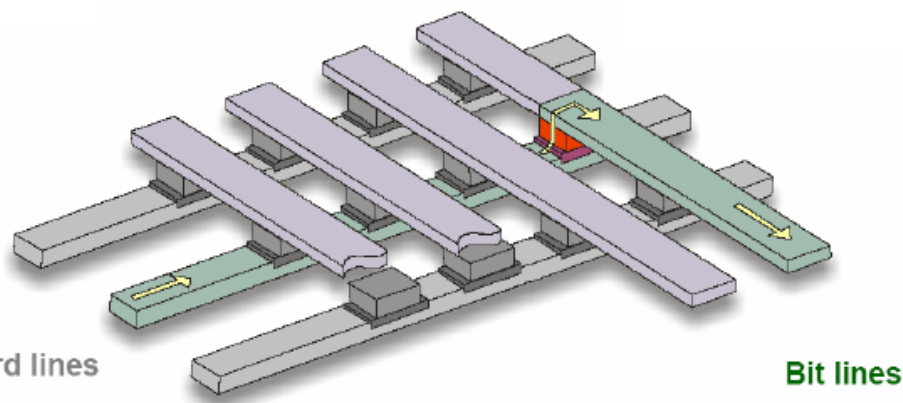


## Spin transfer torque (STT)

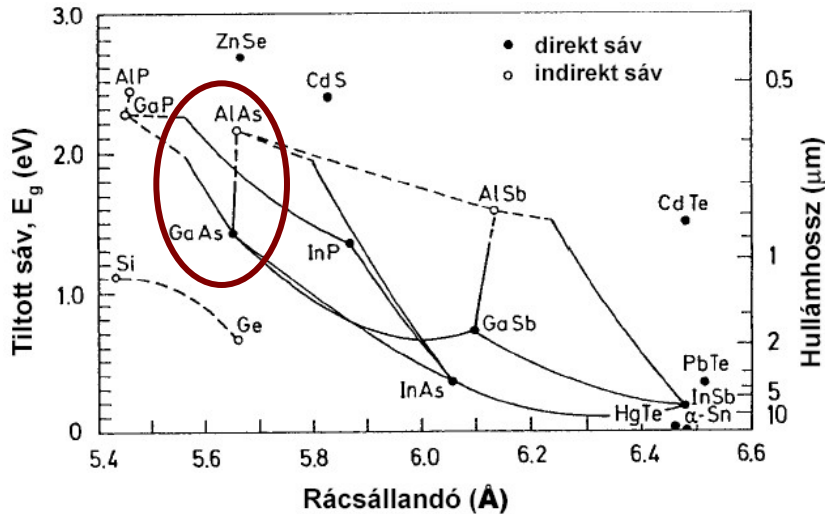
small current – readout  
Large current – data storage



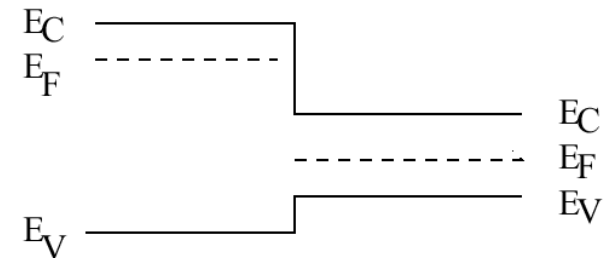
$10^8$ - $10^9$  A/cm<sup>2</sup>



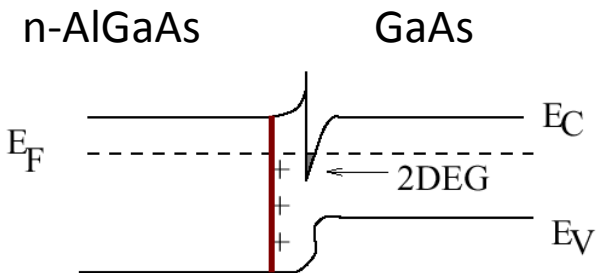
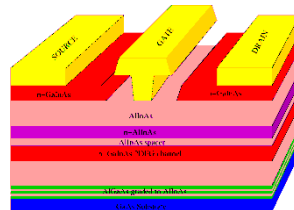
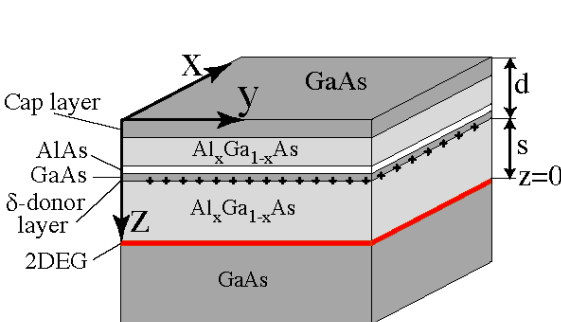
# 2D electron gas in $\text{Ga}_x\text{Al}_{1-x}\text{As}$ heterostructures



The gap of **GaAs** and **AlAs** strongly differs, but their lattice constant is the same with <0.15% precision, therefore they can be grown above each other epitaxially, without lattice defects. If  $\text{Ga}_x\text{Al}_{1-x}\text{As}$  is grown with coevaporation than the gap can be continuously tuned with  $x$  (**band engineering**).



At the interface of AlGaAs and GaAs a two dimensional electron gas (2DEG) is formed, i.e. At the interface the electrons can freely propagate.



Doping is performed further away from the interface, thus the doping atoms do not disturb the motion of the electrons in the 2DEG. Due to this and the epitaxial growth the electrons can travel extremely long distances in the 2DEG without scattering -> high mobility.

**Applications:** High Electron Mobility Transistor, with frequencies up to 600GHz; semiconductor lasers

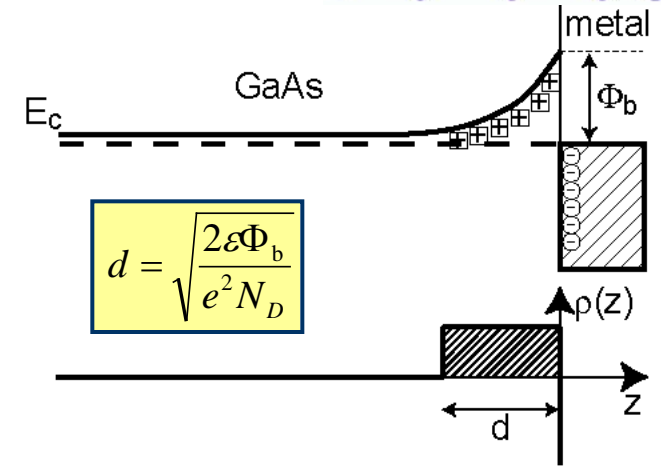


# 2D electron gas in $\text{Ga}_x\text{Al}_{1-x}\text{As}$ heterostructures

## Gate electrodes – Schottky barrier

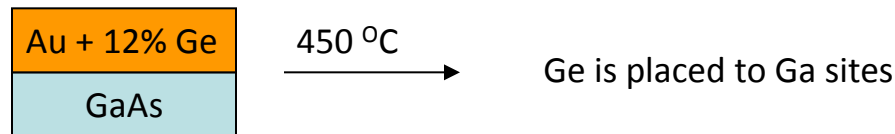
Between a metal and the semiconductor a depleted layer forms. The electrons can only cross this layer by thermal excitation or electron tunneling.

With the gate voltage one can tune the electron density in the 2DEG.

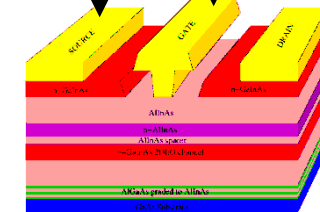


## Ohmic contacts

With strong doping the Schottky barrier can be destroyed, and so ohmic contacts can be formed.



Ohmic contact Gate electrode



## „Split gate” technique

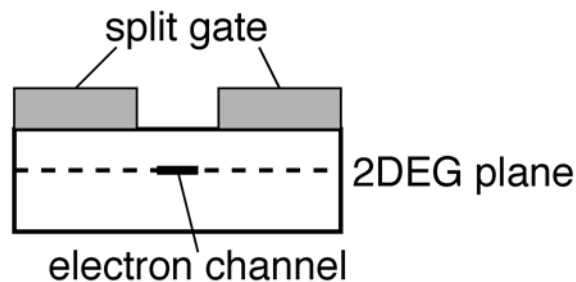
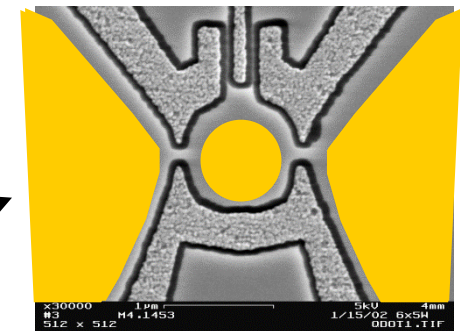


Photo or electron beam lithography is used to place gate electrodes on the top of the 2DEG. With proper gate voltage the electron gas can be depleted underneath the gates.

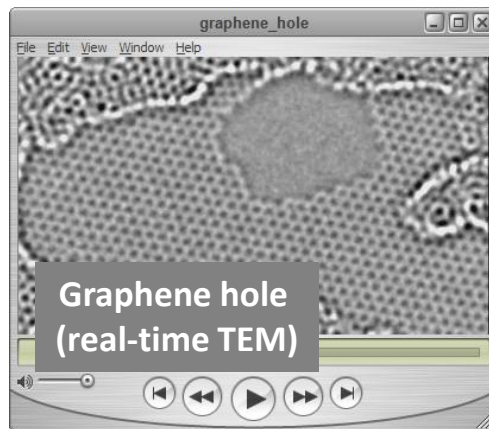
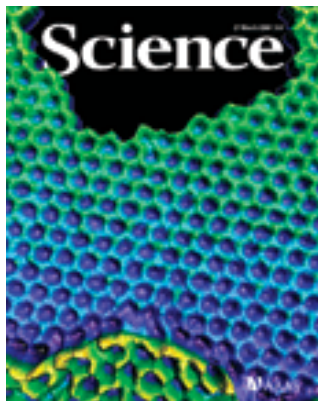
quantum dot



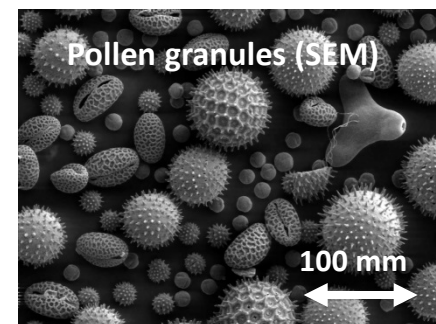
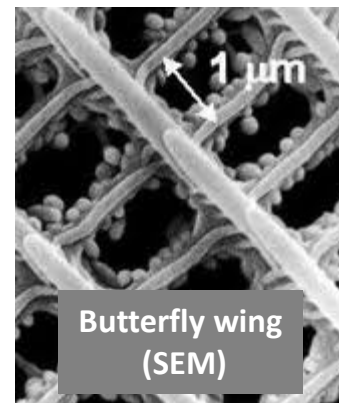
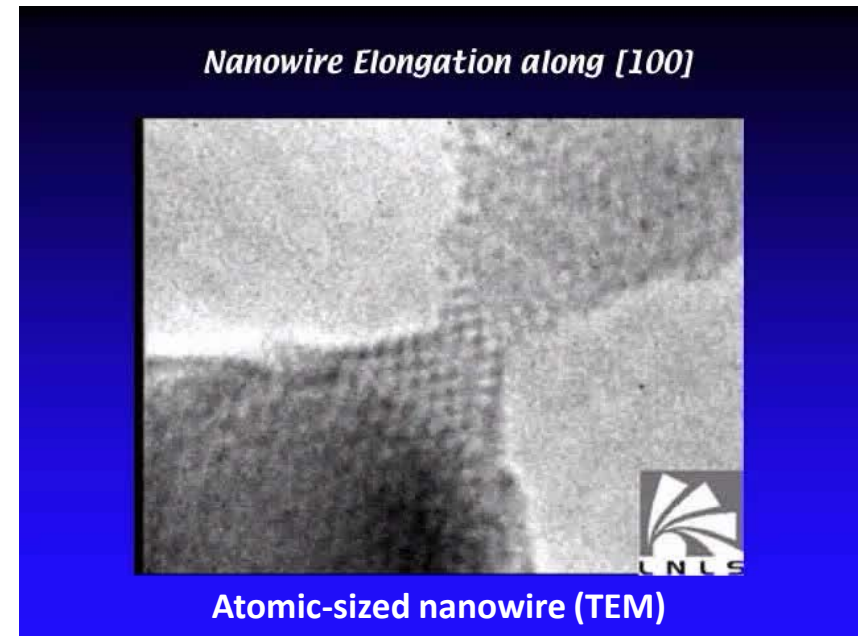
# Scanning and transmission electron microscope (SEM / TEM)



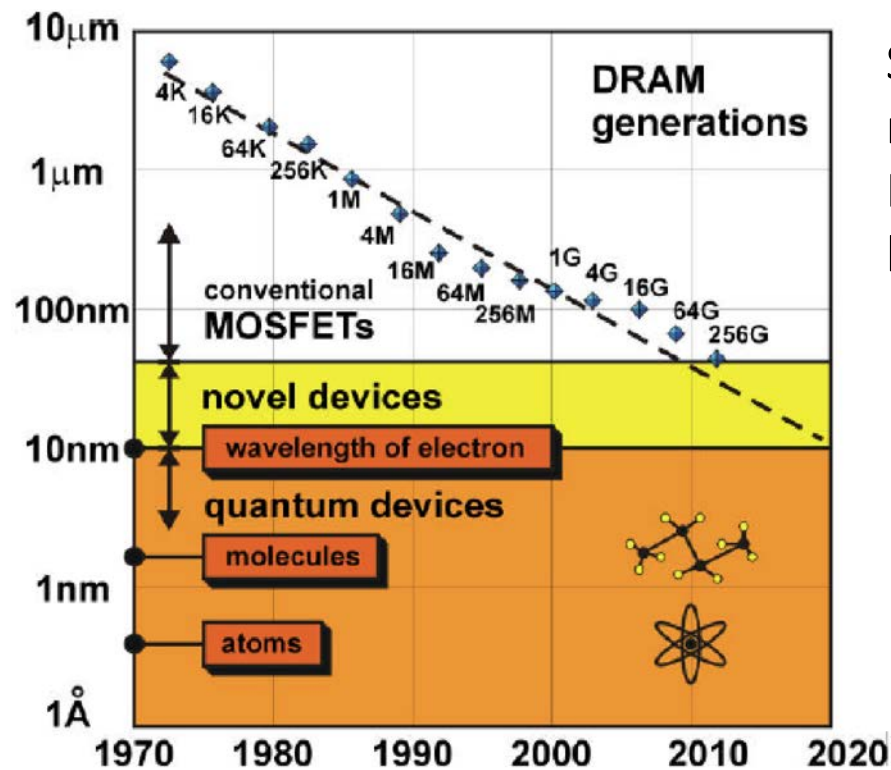
- SEM: the sample is scanned by a focused electron beam, reflected electrons or secondary electrons are detected. 1-5 nm resolution.
- TEM: the electron beam is transmitted through an ultra thin layer, the picture is magnified by electron optics.



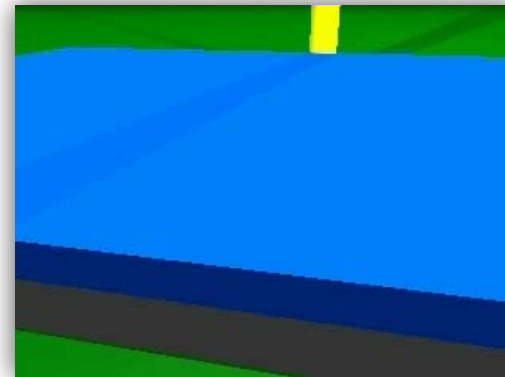
Girit et al. Science **323**, 1705 (2009)



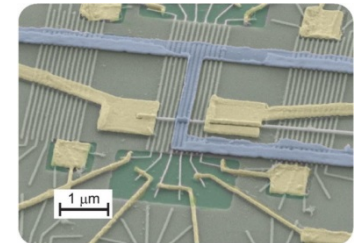
# How can we fabricate nanocircuits?



Scanning electron microscope in the BME – MFA joint laboratory



Electron beam lithography



A silicon substrate is covered by a polymer (PMMA) film. The structure of the PMMA changes where it is shined by the e-beam. At these regions the PMMA can be removed with a solvent. Afterwards metal is evaporated, and finally the rest of the PMMA (with the metal on the top) is removed by an other solvent. A metal wire is left, where the structure was shined by e-beam.

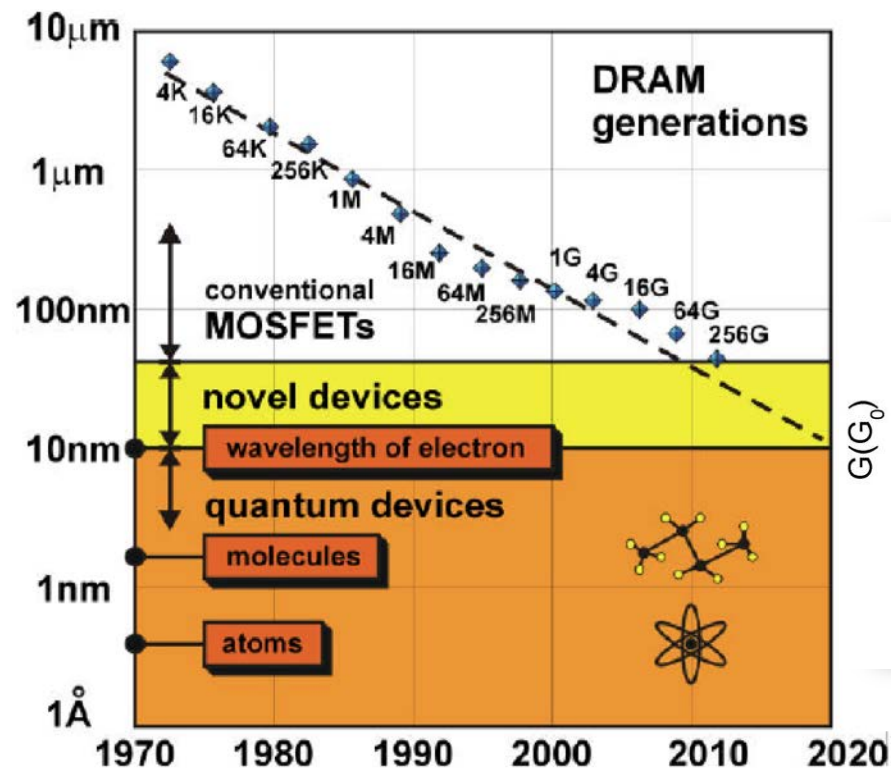


Ernst Ruska,  
Nobel prize  
1986.



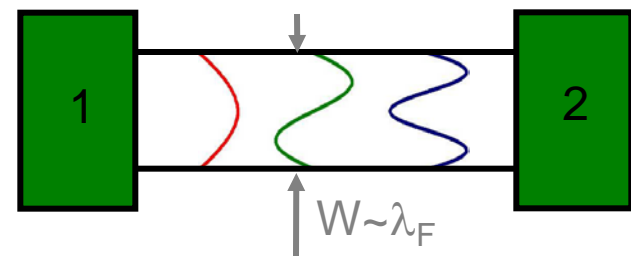
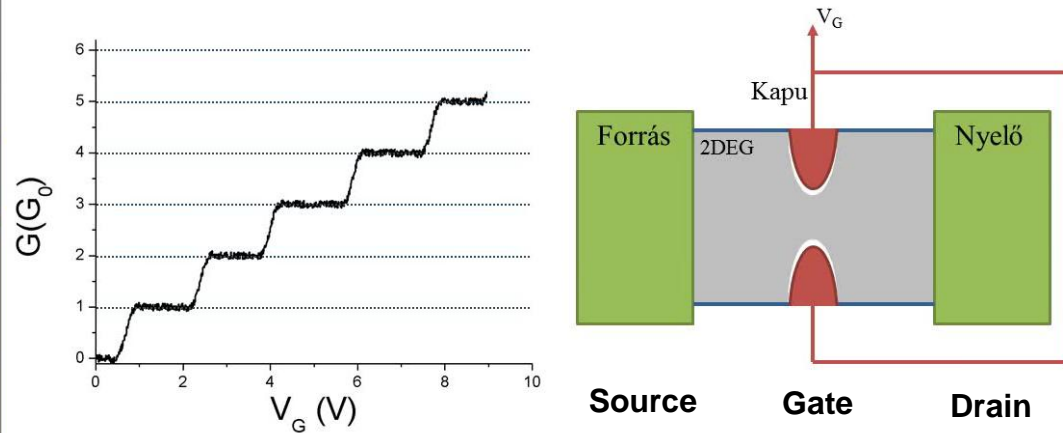
„for his fundamental work in electron optics, and for the design of the first electron microscope”

# Surprising phenomena at nanoscale



The conductance of a two dimensional electron gas changes in steps of  $G_0 = 2e^2/h$  as the width of the channel is tuned by gate electrodes, if the channel width is in the order of the electron wavelength. The conductance steps correspond to the opening of discrete conductance channels, which are related to transverse standing waves.

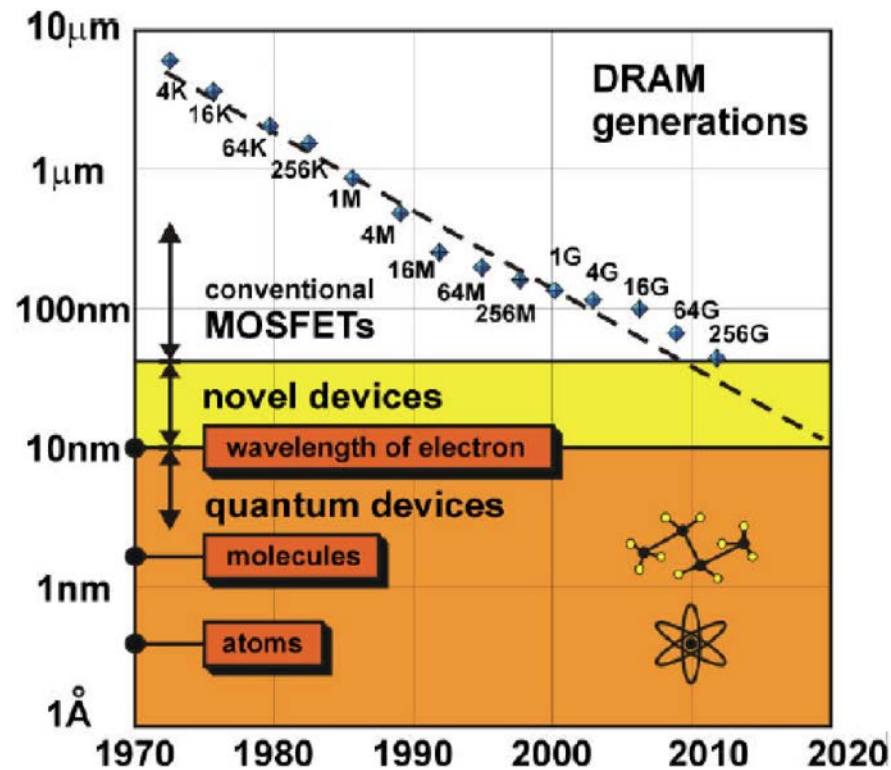
## Wave nature of electrons, conductance quantization



In semiconductors the electron wavelength is  $\lambda_F > 10$  nm, smaller devices are not conducting!

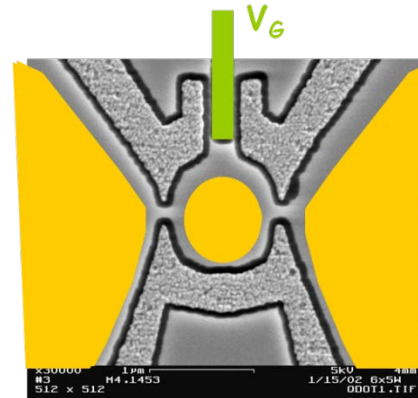


# Surprising phenomena at nanoscale



A metallic island is connected to the source and drain electrodes via tunnel barriers. The addition of an extra electron to the island costs Coulomb energy, therefore at low temperature ( $kT < E_C$ ) the current through the quantum dot is blocked. However, by gate tuning the electrostatic potential of the dot one can set discrete potential values where the presence of  $N$  or  $N+1$  electron is energetically equivalent, and so current can flow through the dot.

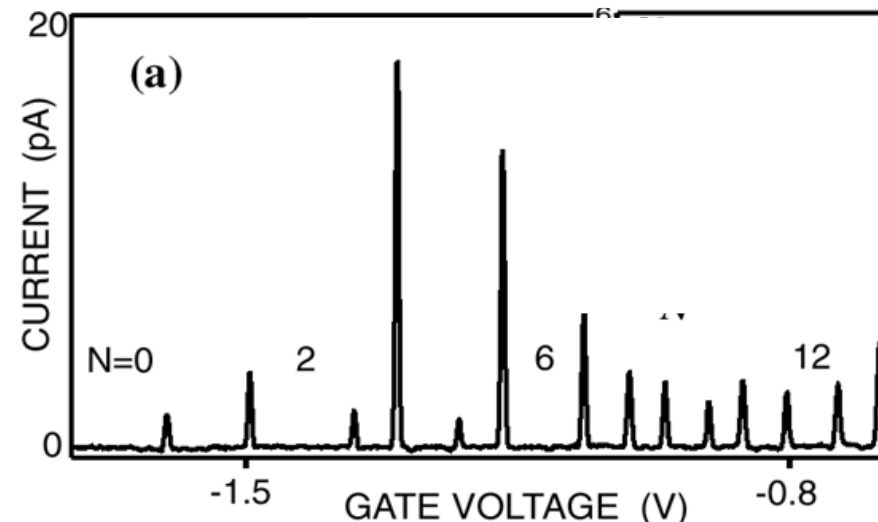
Particle nature of electrons:  
quantum dots,  
single electron transistor



$$E_{\text{Coulomb}}(N) = \frac{e^2 N^2}{2C}$$

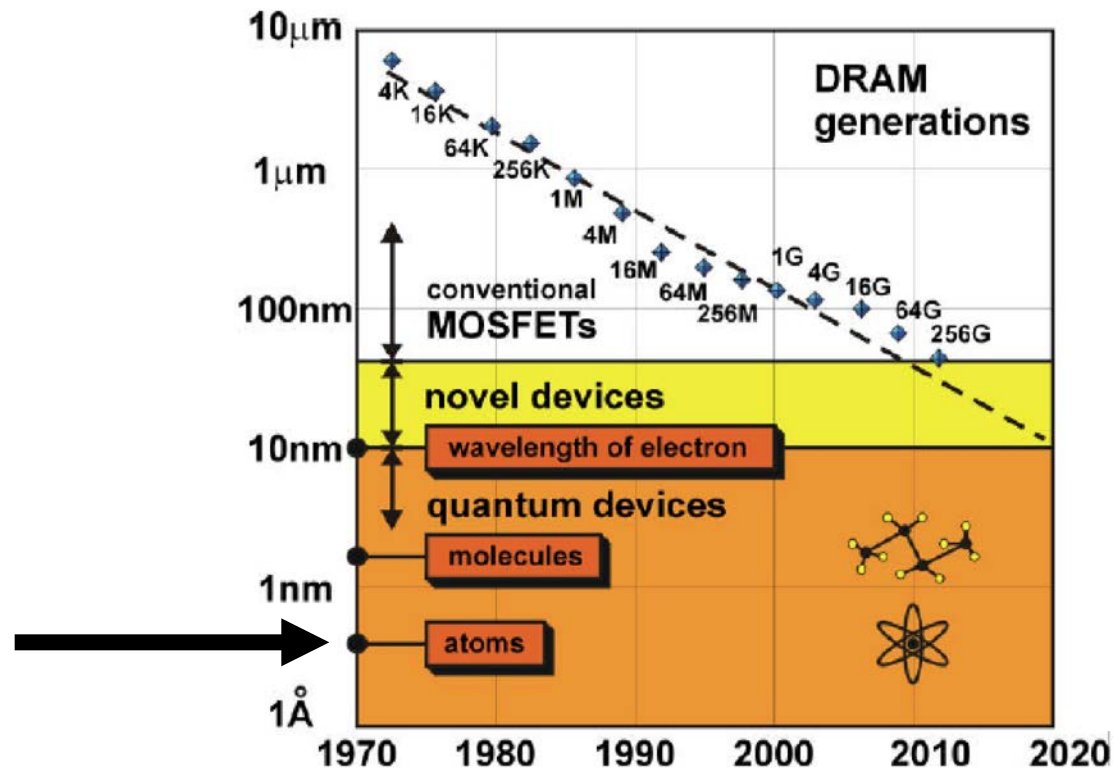
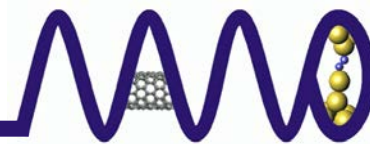
The energy required to  
add a single electron  
(charging energy):

$$\Delta E_c \approx \frac{e^2}{C} \sim 1 \text{ meV} \approx 11 \text{ K}$$

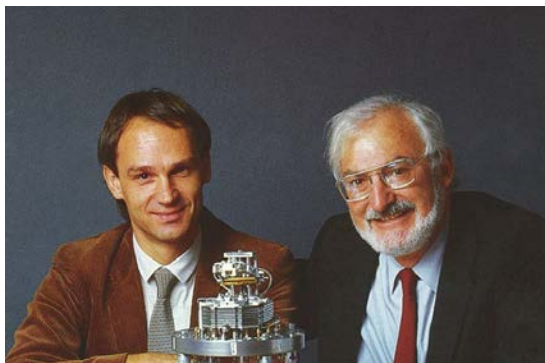
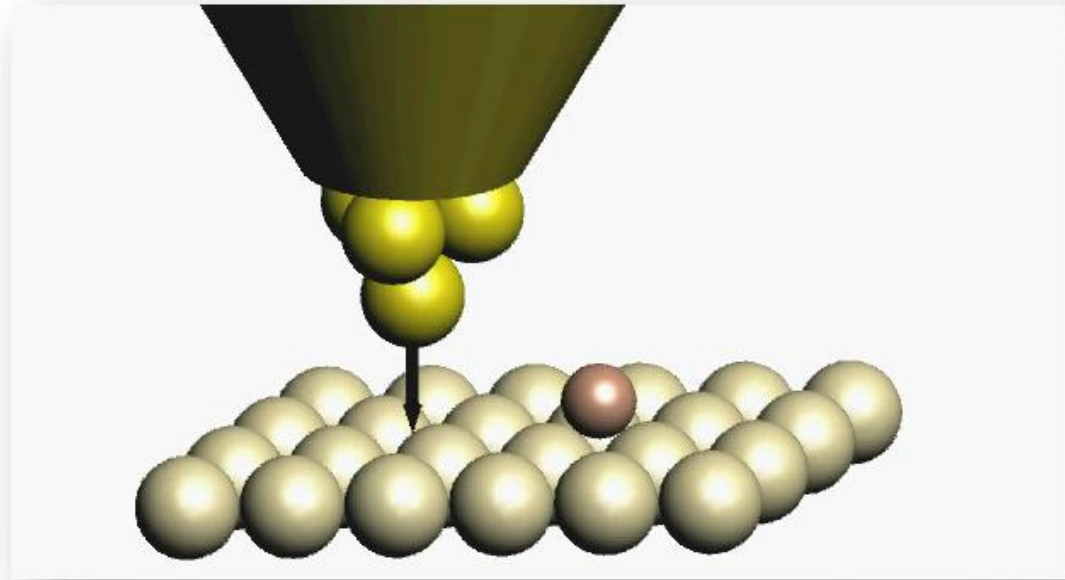
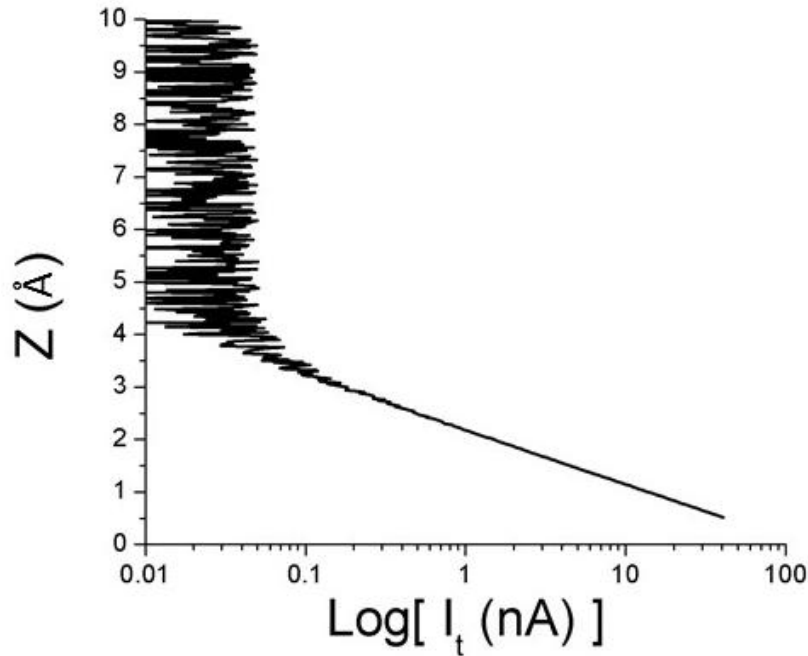
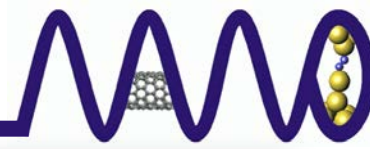




# Atomic-sized structures?



# Scanning tunneling microscope (STM)



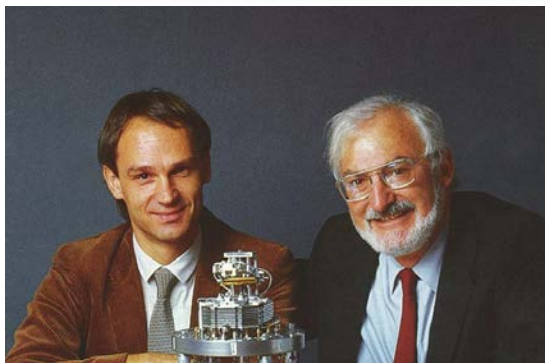
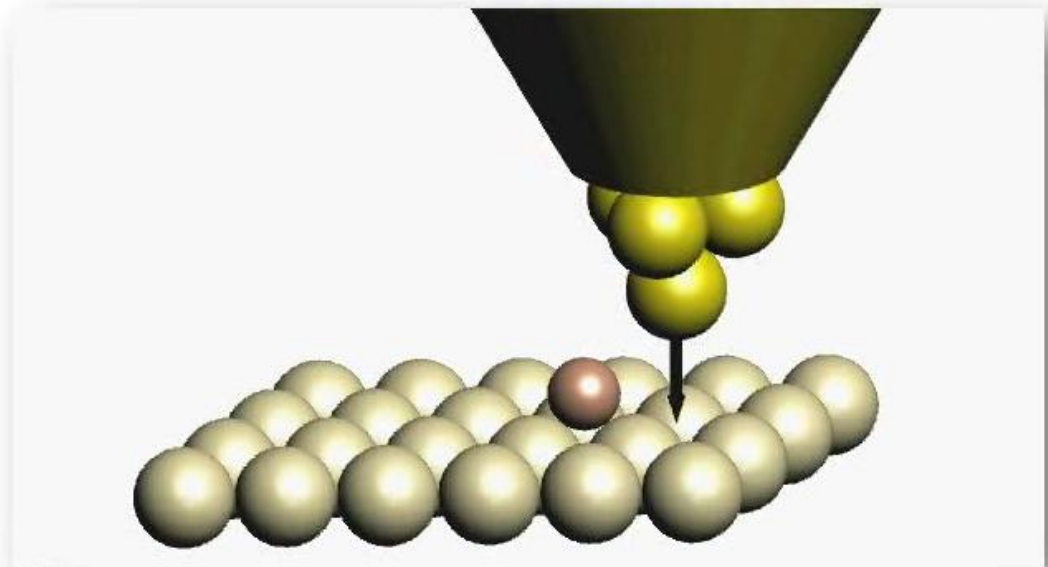
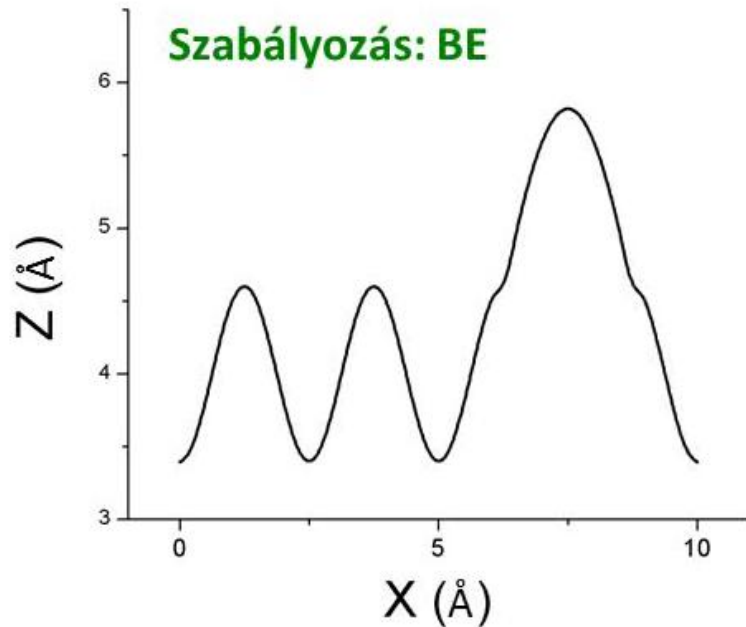
**Gerd Binnig, Heinrich Rohrer**  
Nobel prize 1986.



**„For their design of the scanning tunneling microscope“**

If a biased metallic tip is brought close to a grounded metallic surface a tunnel current flows, though there is an air gap between the tip and the surface. The tunnel current is an exponential function of the tip-surface separation, lifting the tip by a half atom-atom distance ( $\sim 0.1$  nm) causes an order of magnitude decrease in the tunnel current.

# Scanning tunneling microscope (STM)



Gerd Binnig, Heinrich Rohrer  
Nobel díj 1986.



**„For their design of the scanning tunneling microscope"**

As the tip scans over the surface it is raised or lowered by a feedback loop such that the tunnel current, i.e. the tip-sample distance remains constant along the scanning. By plotting the  $z$  position of the tip as a function of  $x$  and  $y$  one can map the topography of the surface even with atomic resolution.

# Scanning tunneling microscope (STM)



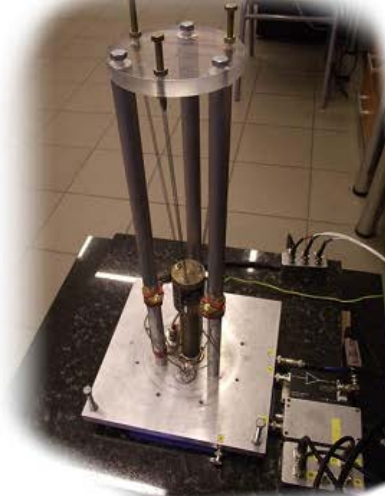
## Self-designed STM:



(a)



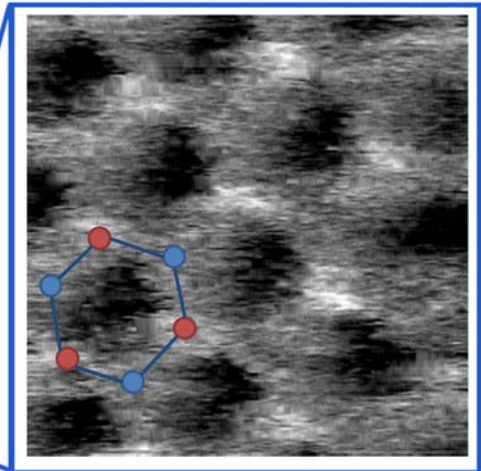
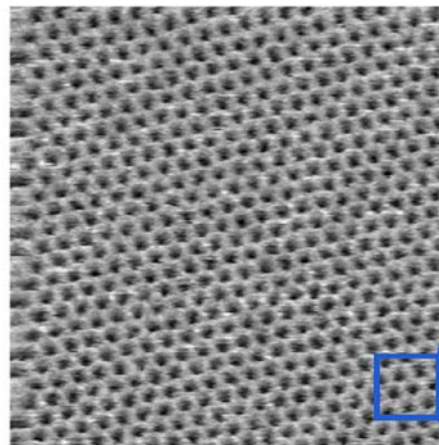
(b)



(c)

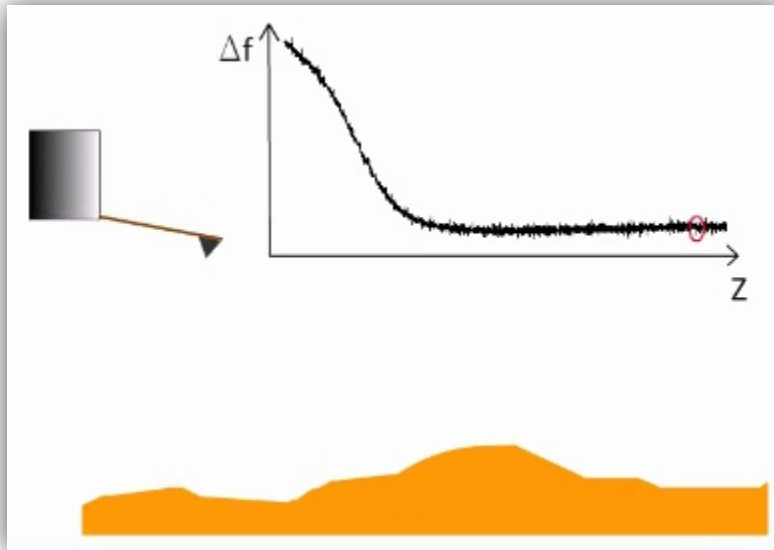


**Atomic resolution  
picture on graphite**

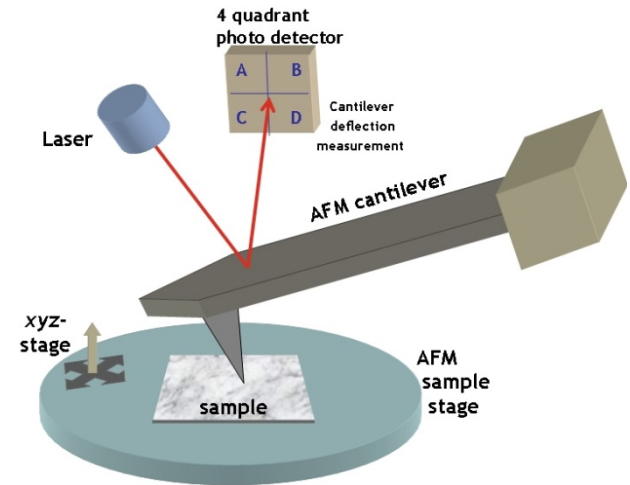




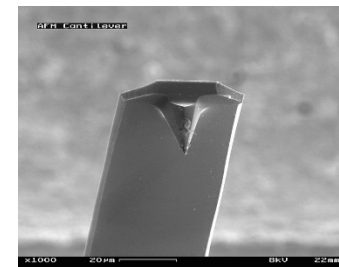
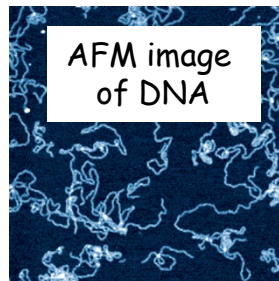
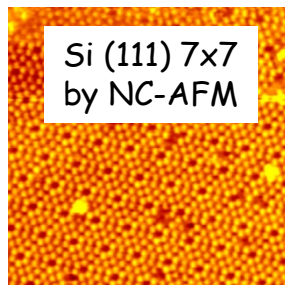
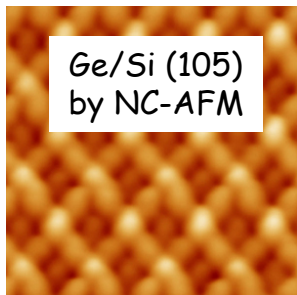
# Atomic force microscope



A tip is placed at the end of a cantilever. The tip is raised and lowered by the feedback such that the **force** between the tip and the sample remains constant. The force is determined from the cantilever deflection or the resonance frequency shift. It works also with non-conducting samples.

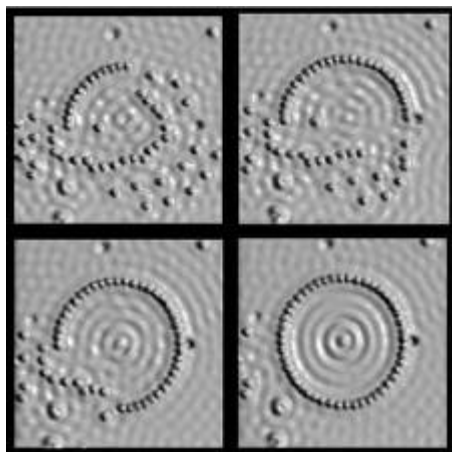


100  $\mu\text{m}$

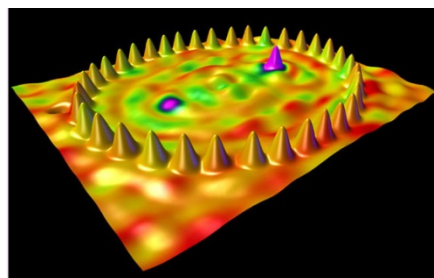




# „Building” nanostructures with an STM

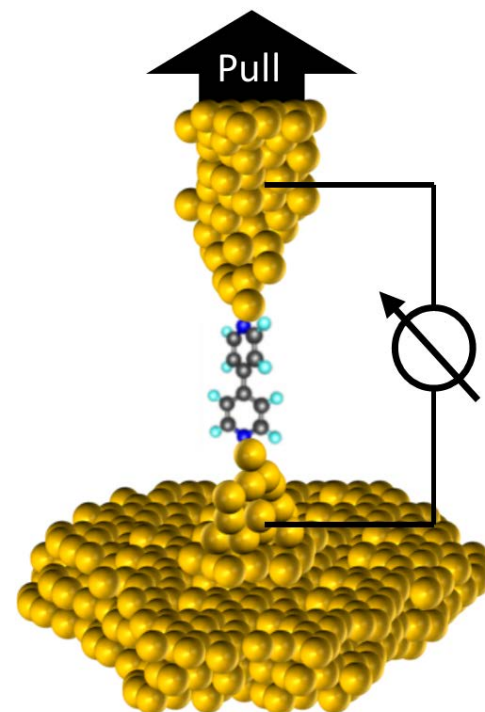


Moving atoms on metal surfaces

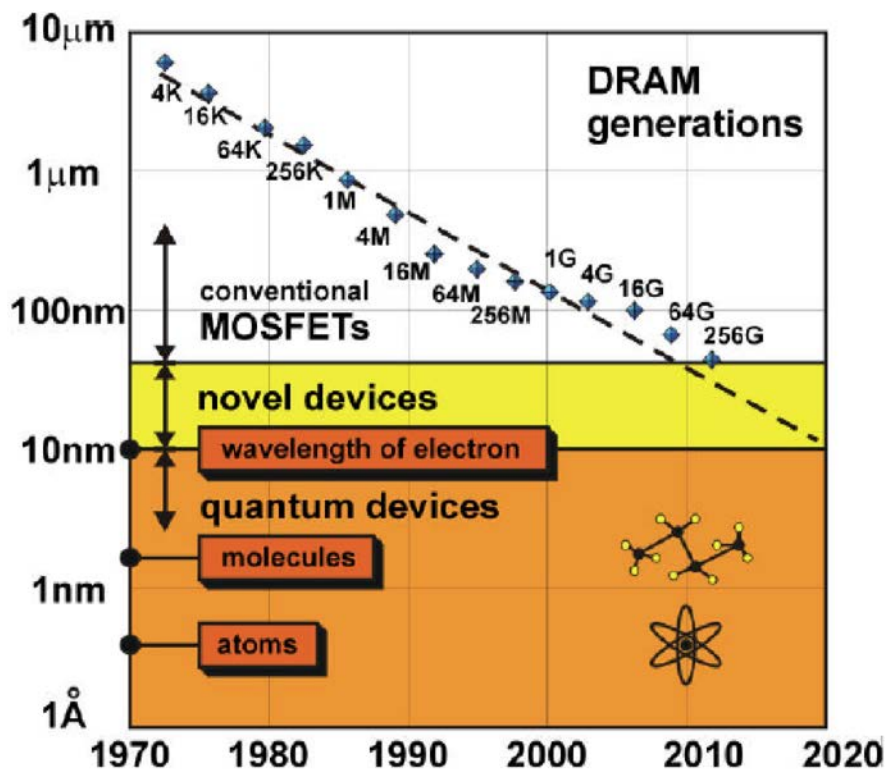
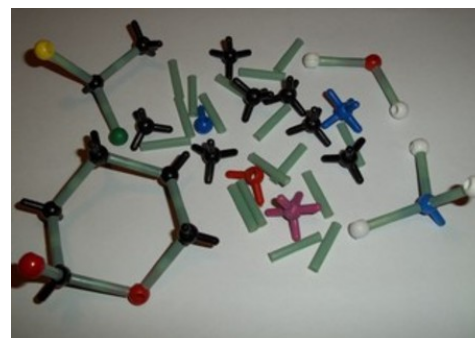


Pulling atomic chains

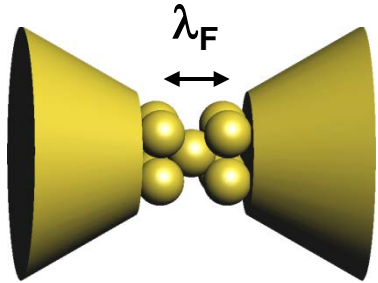
Molecular electronics?



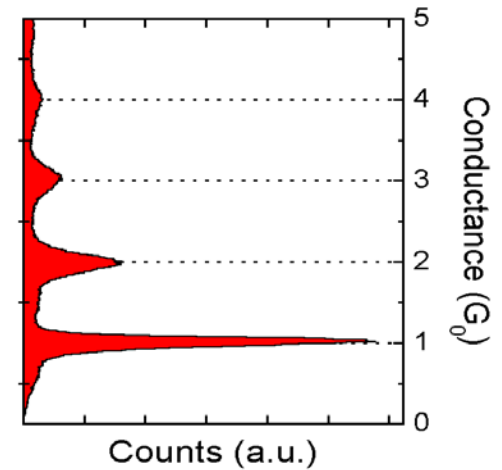
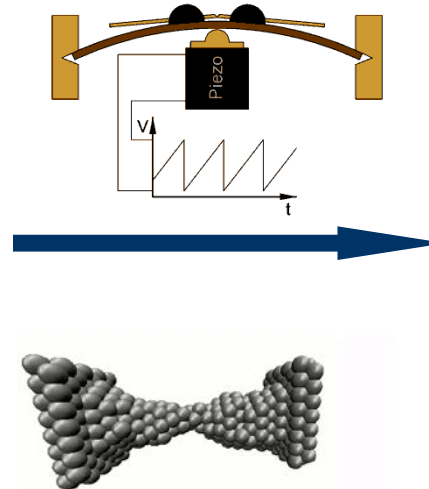
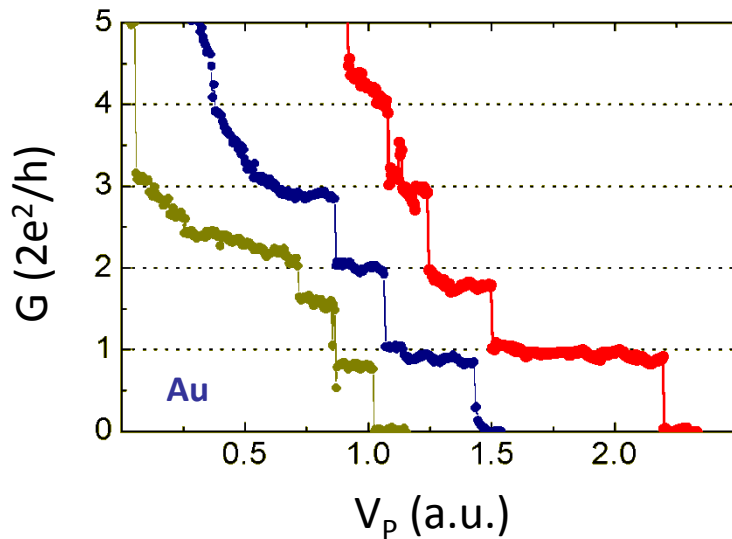
Bottom-up



# Nanostructures from metals?

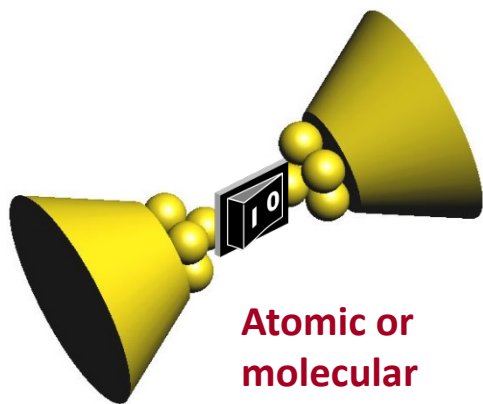
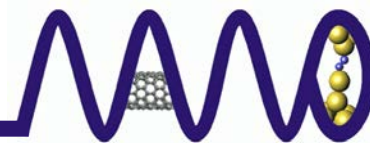


In metals  $\lambda_F \sim$  lattice constant



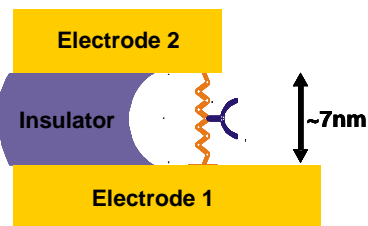
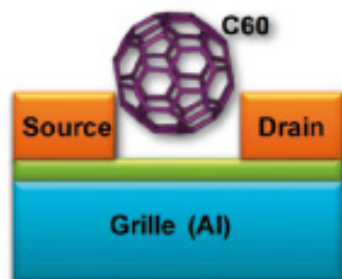
Field effect does not work!

# Molecular electronics?



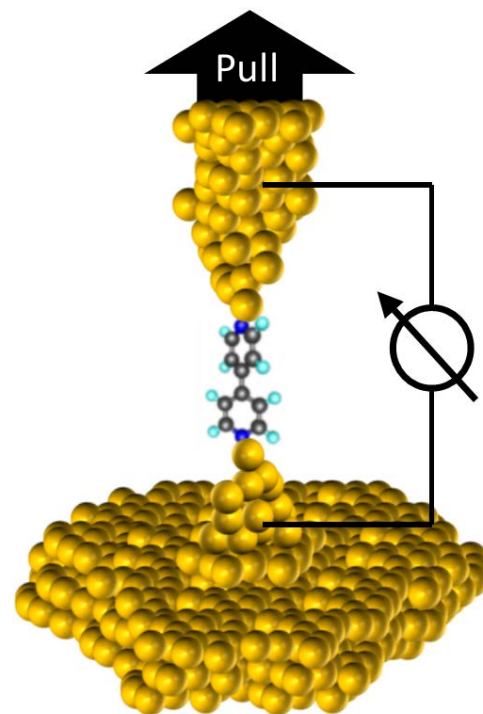
Atomic or molecular memories

Transistor from a single molecule

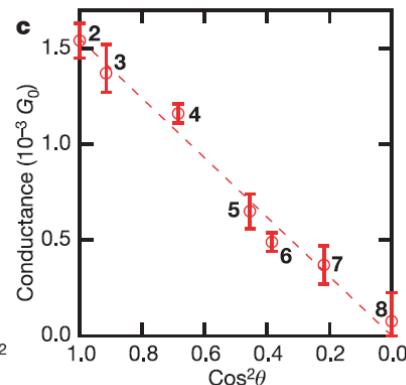
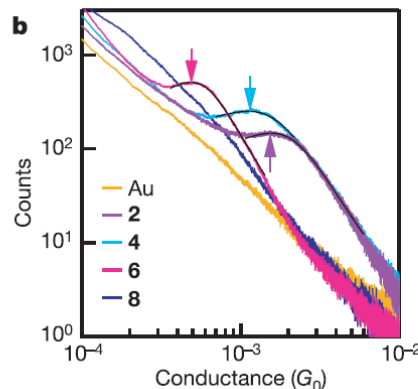
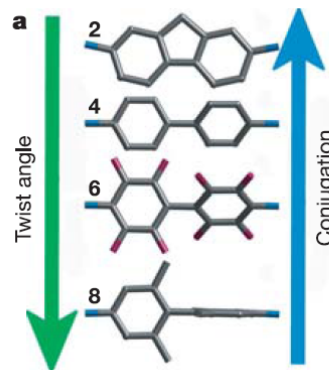
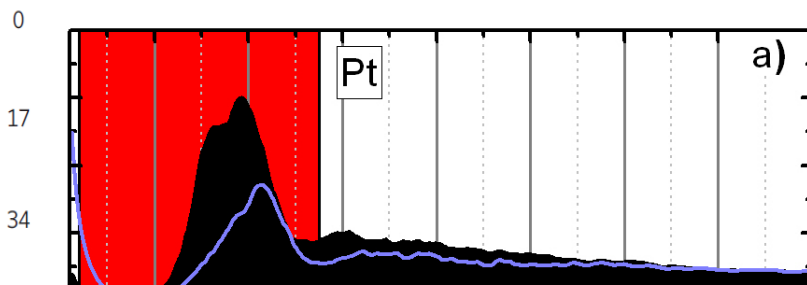
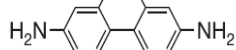
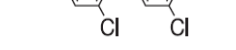
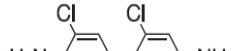
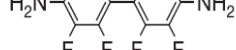
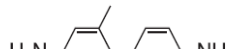
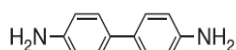
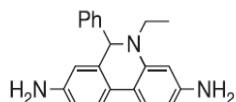
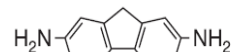


Electrode arrangement

Sensor from a single molecule



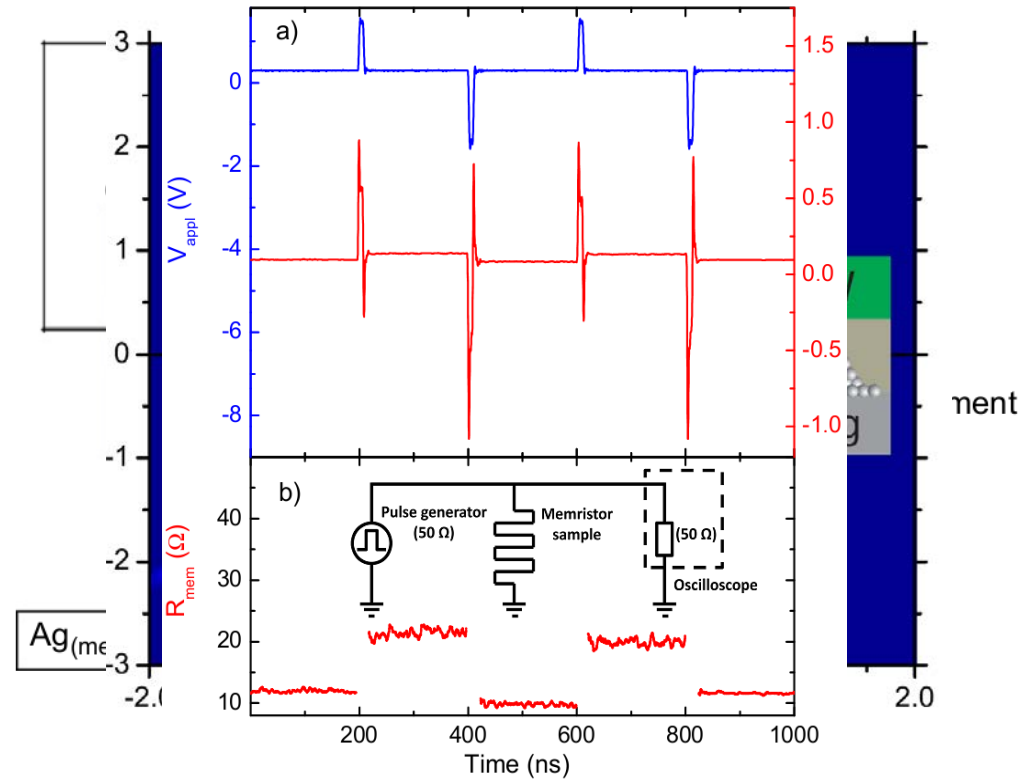
10  $\mu\text{m}$



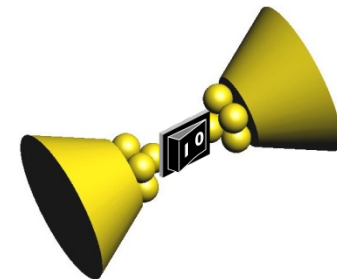
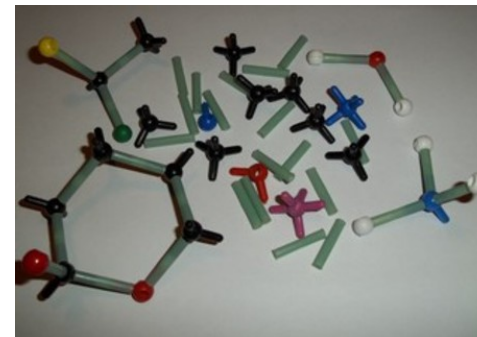
# Nanoionics?



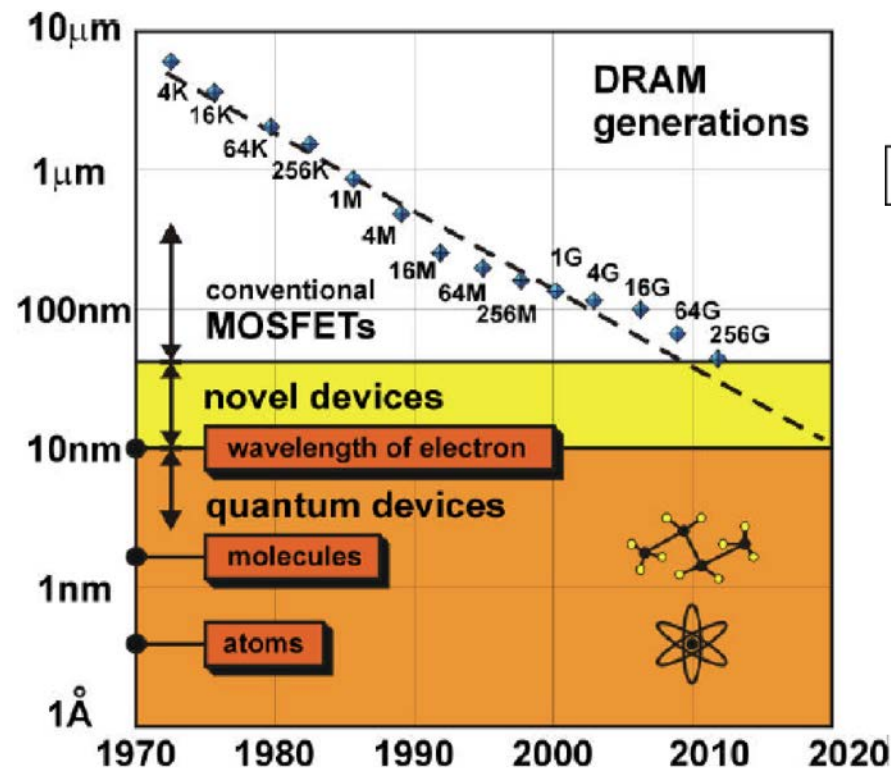
- Atomic-sized memory
- GHz-operation



Bottom-up



Atomic switch

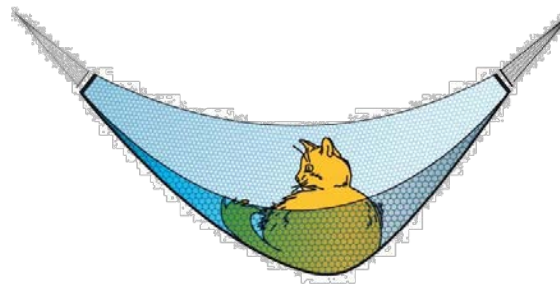
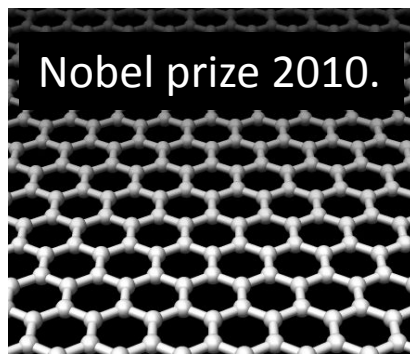




# Graphene



Nobel prize 2010.

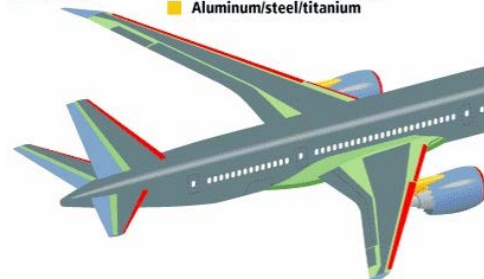


stretchable

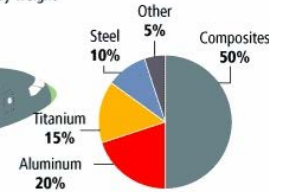
strong composite materials

Materials used in 787 body

- Fiberglass
- Carbon laminate composite
- Aluminum
- Carbon sandwich composite
- Aluminum/steel/titanium

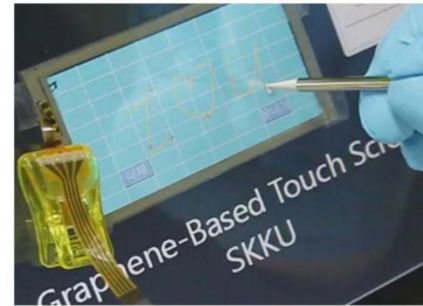


Total materials used  
By weight



By comparison, the 777 uses 12 percent composites and 50 percent aluminum.

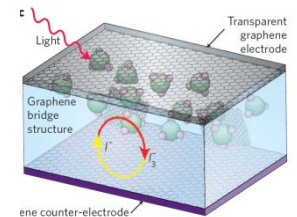
SKKU Touch screen



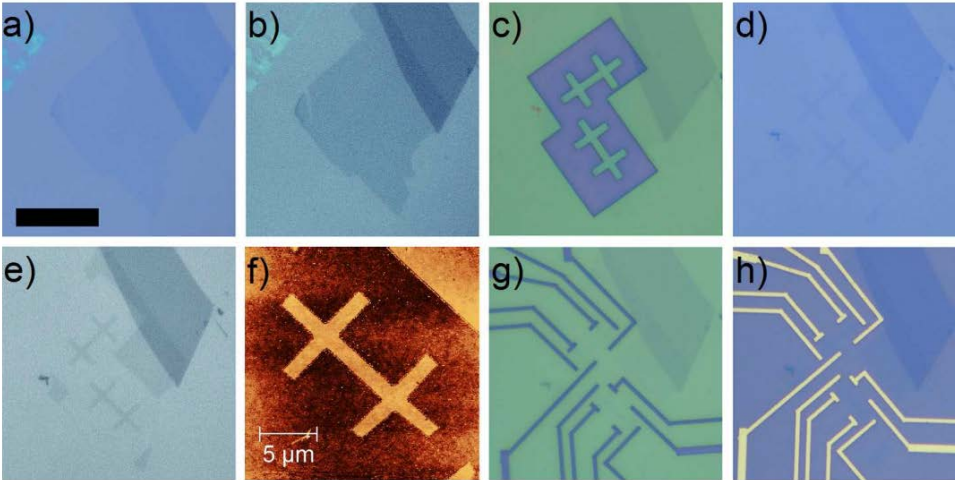
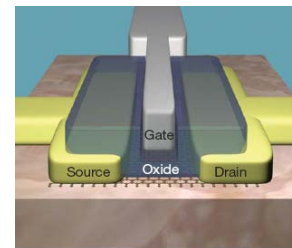
Bae, S. et al. Nature Nano (2010)

touch screen  
(transparent conductor)

photocell



transistor



Quantized  
Hall effect

